

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor..... Luan C. Tran
Assignee..... Micron Technology, Inc.
priority Group Art Unit 2812
priority Examiner Kennedy, Jennifer J.
Attorney's Docket No. MI22-2356
Title: Methods of Forming Semiconductor Constructions

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
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AMENDMENTS